

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

X. INOUE et al.

Serial Number: 09/228,148

Filed: January 11, 1999

For: **MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE INCLUDING AN INSULATION FILM ON A CONDUCTIVE (AS AMENDED)**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents  
Washington, D.C. 20231

Date: August 20, 2001


Sir:

Applicants petition the Commissioner of Patents to extend the time for response to the Office Action dated March 21, 2001, for two months from June 21, 2001 to August 21, 2001.

Attached please find a check in the amount of \$390.00 to cover the cost of the extension. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340. This paper is filed in triplicate.

Respectfully submitted,

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Group Art Unit: 2823

Examiner: K. Eaton

